



Patent  
Atty. Docket No. AMAT/4714.D1/PCG/WCVD/BG

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

RECEIVED  
OCT 25 2002  
TC 1700

In re Application of:  
Kori, et al.

Serial No.: 09/625,336

Confirmation No.: 7523

Filed: July 25, 2000

For: METHOD AND SYSTEM FOR  
CONTROLLING THE  
PRESENCE OF FLUORINE IN  
REFRACTORY METAL LAYERS

Group Art Unit: 1763

Examiner: Moore, Karla A.

# 16B  
10/25/02  
ML

Commissioner for Patents  
Washington, D.C. 20231

Dear Sir:

CERTIFICATE OF MAILING 37 CFR 1.8	
I hereby certify that this correspondence is being deposited on 10/18, 2002 with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231.	
10/18/02 Date	<i>Kent M. Suber</i> Signature

RESPONSE TO OFFICE ACTION DATED JULY 18, 2002

In response to the Office Action dated July 18, 2002, having a shortened statutory period for response set to expire on October 18, 2002, please enter this response and reconsider the claims pending in the application for reasons discussed below. Although Applicant believes that no fee is due in connection with this response, the Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/AMAT/4714.D1/BTP \$426.00 for 5 additional claims in excess of 20, including 4 additional independent claims in excess of 3, and for any fees, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.

IN THE CLAIMS:

Please amend the claims as follows:

10/24/2002 AOSMAN1 00000058 200782 09625336

01 FC:1201 336.00 CH  
02 FC:1202 90.00 CH